

<b>Notice of References Cited</b>	Application/Control No. 10/685,738		Applicant(s)/Patent Under Reexamination KIM ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0119615	08-2002	Kim et al.	438/201
*	B	US-2003/0102504	06-2003	Chern et al.	257/321
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	K	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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